

PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Michial D. Howell et al.

Application No.: NEW

Filed: HEREWITH

For: METHOD AND APPARATUS FOR
PREPARING SEMICONDUCTOR
WAFERS FOR MEASUREMENT

Group No.: Unknown

Examiner: Unknown

SUBMISSION OF FORMAL DRAWINGS

M/S PATENT APPLICATION

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

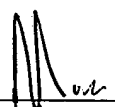
Sir:

Enclosed are eight (8) sheets of formal drawings for filing in the above-referenced patent application.

Respectfully submitted,

STALLMAN & POLLOCK LLP

Date: July 22, 2003

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